

FEB 09 2004

Docket No.: Micronas.6287

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**APPLICANT:** Igel et al.

**GROUP:** 2858

**INTERNATIONAL  
APPLN. NO.:** PCT/EP99/10045

**EXAMINER:** Walter Benson

**SERIAL NO:** 09/868,538

**INTERNATIONAL  
FILING DATE:** 17 December 1999

**FOR:** CAPACITIVE MAGNETIC FIELD SENSOR

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

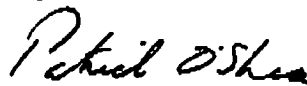
Sir:

**PROPOSED DRAWING AMENDMENT**

Applicant proposes to add FIG. 2 as indicated on the attached sheet.

With the Examiner's approval, the changes will be incorporated into the formal drawings.

Respectfully submitted,



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